Local Structural Investigation of Hafnia-Zirconia Polymorphs in Powders and Thin Films by X-ray Absorption Spectroscopy

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ABSTRACT: Despite increasing attention for the recently found ferro- and antiferroelectric properties, the polymorphism in hafnia- and zirconia-based thin films is still not sufficiently understood. In the present work, we show that it is important to have a good quality X-ray absorption spectrum to go beyond an analysis of the only the first coordination shell. Equally important is to analyze both EXAFS and XANES spectra in combination with theoretical modelling to distinguish the relevant phases even in bulk materials and to separate structural from chemical effects. As a first step toward the analysis of thin films, we start with the analysis of bulk references. After that, we successfully demonstrate an approach that allows us to extract high-quality spectra also for 20 nm thin films. Our analysis extends to the second coordination shell and includes effects created by chemical substitution of Hf with Zr to unambiguously discriminate the different polymorphs. The trends derived from X-ray absorption spectroscopy agree well with X-ray diffraction measurements. In this work we clearly identify a gradual transformation from monoclinic to tetragonal phase as the Zr content of the films increases. We separated structural effects from effects created by chemical disorder when ration of Hf:Zr is varied and found differences for the incorporation of the substitute atoms between powders and thin films, which we attribute to the different fabrication routes. This work opens the door for further in-depth structural studies to shine light into the chemistry and physics of these novel ferroelectric thin films that show high application relevance.

KEYWORDS: extended X-ray absorption fine structure; X-ray absorption near edge structure; ferroelectrics; hafnium oxide; zirconium oxide

1 INTRODUCTION

The polymorphism of hafnia and zirconia has been intensely studied, first as ceramics in the frame of refractories^{1,2} and solid electrolytes (oxygen conduction)^{3,4}, transformation toughening ("ceramic steel")^{5,6,7} and later, in the quest for so-called "high-k dielectrics" (dielectrics with higher relative permittivity than 3.9) to replace SiO₂ in both transistors and capacitors of semiconductor industry^{8,9}. This is why a 2011 publication by Böscke et al.¹⁰ claiming ferroelectric behavior in 10 nm thick Si:HfO₂ films took researchers by surprise. The understandable doubts steadily reduced in the following years as reports of similar properties induced by a wealth of dopants and studies by different groups using unique fabrication methods and various electrode materials suggested some universality – at least for thin film samples.^{11,12,13,14,15,16,17,18,19,20} Further "must-haves" for a ferroelectric, beyond a hysteretic curve of polarization P vs. electric field E, such as counter-clockwise switching in a ferroelectric field-effect transistor (FE-FET)^{21,22}, piezo-^{10,23} and pyroelectricity^{24,25}, as well as the experimental proof of the presence of a polar phase^{26,27}, solidified the original claim of Böscke et al.¹⁰. The implementation of these new class of fluorite-type ferroelectrics in first devices for memory (transistor²¹ and capacitor²⁸ based), energy harvesting and electrocaloric cooling²⁹ or supercapacitors^{30,31} applications was even faster than the actual proof of the claimed phase behind. In recent years the pool of applications has been expanded by the new concept of antiferroelectric memory³², neuromorphic devices^{33,34} negative capacitance FETs³⁵, ferroelectric tunnel junctions³⁶ as well as tunable microwave filters and phase shifters $37,38$.

Nonetheless, fundamental material research could not keep pace with this encouraging development. This is due to the following aspects:

- 1) Most of the utilized films are polycrystalline and contain a mixture of phases. A wealth of potential polymorphs exists and especially the many orthorhombic phases are only distinguished by the oxygen sublattice 26 , which is not easily accessible via standard X-ray diffraction (XRD) methods.
- 2) A size effect is involved in the occurrence of ferroelectricity^{39,40,41}. Most of the ferroelectric films are less than 30 nm thick and even for epitaxial films, the orthorhombic phase relaxesinto the monoclinic bulk phase beyond a certain thickness.^{18,42,43,44,45}
- 3) Also from theory, i.e. ab-initio simulations, bulk calculations cannot explain the observed ferroelectricity. Computation-intense "real world" parameters like dopants, vacancies, strain or surface energy have been included to come closer to an explanation, but the work is still ongoing.^{39,46,47,48}

Up to now, the best insights into the structure are provided by high-resolution, aberration-corrected transmission electron microscopy (TEM) methods.^{26,27,49,50} However, thin lamellas have to be cut for TEM analysis, which raises the questions if the film still remains unchanged. Moreover, sampling is poor in polycrystalline films as only grains that, by chance, are oriented in a lower-index axis toward the beam can be analyzed. Here, extended X-ray absorption fine structure (EXAFS) analysis comes into play. This method is suited to study the application relevant capacitor stacks of a dielectric film sandwiched between two electrodes as it is used in ferroelectric memories.

X-ray absorption spectroscopy (XAS) is an atomic site-specific probe⁵¹, which, differently from XRD, does not require any long-range crystal symmetry and hence can be used to directly access the local atomic structure of matter, including crystalline and amorphous states. By EXAFS it is possible to quantify interatomic distances, the kind and the number of surrounding atoms as well as their disorder around an absorber, and it is particularly suited to investigate local strain.^{52,53,54,51} In future, EXAFS could be a very powerful method to study all applicationrelevant pre-conditioning or degradation^{55,49,56} mechanisms.

However, strong parameter correlations limit the investigation of complex problems and the data analysis relies on the best possible choice of boundary conditions and initial guesses. Here, a look into literature is the first step and there is already a solid body of EXAFS data for hafnia and zirconia available^{57,58,59,60,61,62,63}. Very comprehensive studies of zirconia polymorphs and effect of various dopants was performed by Li et al.^{57,64,65,66,67,68}. In these studies, a quantitative analysis of EXAFS data are performed including the first coordination shell (metal-oxygen, Me-O) and second coordination shell (metal-metal, Me-Me). What all studies have in common is that the Me-O and Me-Me distances were grouped into some representative mean value(s). This is mainly done because of the nontrivial structure of the material with many degrees of freedom for the low symmetry lattices, which leads to too many correlated free parameters (coordination numbers, relative distances, mean-square relative displacements often called Debye-Waller factors).

This work starts with a section on theoretical modelling of XAS spectra for the concerned polymorphs and the impact of chemical substitution of Hf with Zr. In the experimental part, we first analyze powder samples of different phases to establish an understanding of the bulk reference phases and their characteristic features. After that, thin films of different dielectric behavior and corresponding structure were approached. Here, the thin film nature, again, warranted some deeper thought regarding sample preparation. In preliminary experiments, the simplest approach of using fluorescence mode to measure 10 nm thin films on 12 nm TiN and Si wafer piece resulted in very low signal quality insufficient for the aforementioned analysis of further coordination shells. Fluorescence mode also suffers the issue of self-absorption, which can in principle be corrected for, but not always sufficiently.⁶⁹ It was thus, decided to use 1) transmission mode, 2) 20 nm thick dielectric films and 3) a thinner and lighter substrate of 125 µm rigid graphite that allows to 4) pile multiple of these capacitor stacks on top of one another. Moreover, instead of hafnia doped by Si or other elements, the binary solid solution of hafnia and zirconia was chosen, to increase the likelihood of obtaining high-quality spectra of two metal edges to be combined in the subsequent analysis. With this approach we were able to achieve a comparably high signal quality for both ceramics and thin film samples.

2 MODELLING OF XAS

To understand the complexity of EXAFS analysis we have calculated the theoretical configuration-averaged EXAFS spectra for the monoclinic (P2₁/c), orthorhombic (Pca2₁) and tetragonal (P4₂/nmc) HfO₂ and ZrO₂ phases. Unit cells as provided by Materlik et al.³⁹, were used in the software FEFF 9^{70} . The spectra were averaged over all atomic positions, which is especially important when modelling the substitution of Hf with Zr. Fourier transform of EXAFS (FT-EXAFS) here and afterwards is performed using a Kaiser-Bessel window in the k -range 3 - 13 \AA ⁻¹ to be comparable with experimental data. In the calculations reported in Figure 1, thermal and static disorder effects are neglected, which results in much larger amplitudes at high wavenumber values k than in a real spectrum. Nonetheless, the *k*-position of the oscillations are unaffected and reliably reflect what trends to expect in a real spectrum.

At low wavenumber values (up to 6 \AA ⁻¹), the signal from the first coordination shell (generally Me-O, here Hf-O and Zr-O) dominates. It is rather close for all polymorphs as it originates from a rather broad distribution of distances. This is especially true for low symmetry phases (e.g. monoclinic or orthorhombic) where it is very hard to distinguish strained phases in thin films just by Me-O distances.⁶¹ Spectral weight observed beyond 10 \AA ⁻¹ stems mainly from the Hf-Hf and Zr-Zr pairs. In this shell, the differences between the three phases are much more pronounced, as the metal positions define the Bravais lattice system – monoclinic, orthorhombic or tetragonal. The tetragonal phase for example, has the most pronounced Me-Me features in the FT-EXAFS plots (Fig. 1c).

Figure 1. Simulated configuration-averaged EXAFS for Hf L₃-edge of HfO₂ polymorphs (monoclinic P2₁/c, orthorhombic Pca2₁, tetragonal P4₂/nmc and cubic Fm $\overline{3}$ m) from Materlik et al.³⁹ (a) their Fourier transform of EXAFS (FT-EXAFS) (b), and corresponding $ZrO₂$ polymorphs with exactly the same structure (c).

Also, in the Fourier transform of the calculated EXAFS spectra (Figure 1b) the spectral differences of the three polymorphs are more pronounced in the second coordination shell, i.e. the metal-metal (Me-Me) distances. Only the tetragonal structure possesses a specific fingerprint for the first coordination shell (Hf-O) seen as double peak at 1.7 and 2 Å. In order to distinguish between polymorphs, we believe it is fundamental to extend the EXAFS analysis beyond the first coordination shell as strain effects might also account for shifts to higher or lower distances.71,44,72,73

Moreover, there are many nonequivalent Me-Me distances for low symmetry structures, which poses a challenge for theoretical calculations and interpretation of the experimental results. The maximum number N of independent parameter in an EXAFS fit is limited by the window in wavenumber *k* and distance *R* used (*N = Δk · ΔR · 2 / π*). Trying to fit experimental signals with a larger number of free parameters leads to fake results. For this reason, in most of the cases, the Me-O distances are approximated by one or two aggregated average distances and Me-Me distance by one to three effective distances.^{57,58,61,62} The distribution of the distances might also stem from strains occurring in thin films and doped materials^{50,71,44,72,73,74} which complicates the analysis even more making the discrimination of the different phases of $Hf_{1-x}Zr_xO_2$ compounds a serious challenge. Therefore, spectra with high data quality beyond 10 Å-1 are mandatory. This is a challenging experimental task as data at high *k* values are damped by static and thermal disorder, and sometimes limited by experimental noise.

An important difference seen in FT-EXAFS for Zr K-edge compared to Hf L₃-edge spectra of the pure oxides are sharper (narrower and with higher amplitude) features corresponding to the second coordination shell of the metal for the Zr-Zr compared to the Hf-Hf for identical structures in all phases. This is a consequence of different values and shape for photoelectron effective back scattering amplitude $(F_i(k))$ and phase shift $(\Phi_i(k))$ as a function of wavevector (k) (see Figure S17 in the Supporting Information) [51]:

$$
\chi(k) = S_o^2 \sum_j \frac{N_j}{k r_j^2} F_j(k) \exp(-2\sigma_j^2 k^2) \sin\left(2kr_j + \Phi_j(k)\right),\tag{1}
$$

where $\chi(k)$ is EXAFS signal, r_i is distance between absorbing atom and backscattering atom j, N_i is a number of the atoms j at the distance r_j , σ_j^2 is a mean square relative displacement (variation of the r_j due to static and thermal disorder, sometimes called Debye-Waller factor), $F_i(k)$ and $\Phi_i(k)$ are effective back scattering amplitude and phase shift for atom pair absorbing atom-atom j , S_o^2 is an amplitude reduction factor. These differences seen in the FT-EXAFS and EXAFS spectra for identical structures of HfO₂ and ZrO₂ should be considered when analysing experimental spectra. Without this knowledge one can easily come to misleading conclusions that the Zr-Zr distances have smaller variations than Hf-Hf ones.

Impact of Zr Content on Simulated EXAFS Spectra

Figure 2. Simulated configuration-averaged FT-EXAFS of Hf L₃-edge (a) and Zr K-edge (b) for the monoclinic phase of $Hf_{1-x}Zr_{x}O_{2}$ compounds with different Zr concentrations (percentages denote the Zr content). The arrow indicates the changes found for increasing Zr content (red via orange, yellow and green to blue line): first the characteristic Me-Me features caused by interactions with surrounding Hf atoms (red line) get damped out, then the characteristic features from surrounding Zr atoms (blue line) appear. The corresponding simulation data for the orthorhombic and tetragonal phase as well as the plot of the EXAFS signal can be found in Figures S13 and S14 in the SI.

Other important outcome from this formula is that the features (peaks) in FT-EXAFS spectrum that correspond to the coordination shells (like Hf-O or Hf-Hf) are distorted due the effective back scattering amplitude ($F_i(k)$) and phase shift ($\Phi_i(k)$) which are highly nonlinear functions (Figure S17 in the Supporting Information), so the shape and distance do not correspond to the pair distribution functions. As these phase shifts are specific to every chemical element, it also not possible to speculate about for example Zr-Zr and Hf-Hf distances just comparing the FT- EXAFS peaks. At the same time for polymorphs of the same chemical composition shift in the peak positions in FT-EXAFS can be related with the real shift of the average distances, only change in disorder also should be taken into account.

In Figure 2, we modelled the substitution of the Hf with Zr for the monoclinic phase. The Hf atoms were replaced in a systematic way with Zr (all possible combinations) and made an average of the obtained signal from all nonequivalent atomic positions.

For the FT-EXAFS spectra of the Hf L₃-edge, we see two major effects: an enhancement of the signal from the second coordination shell (Hf-Me) and a shift of the Hf-Me feature to shorter distances as a consequence of different photoelectron backscattering amplitude and phase shift of Zr compared to Hf. The amplitude of Hf-Me feature in FT-EXAFS decreases for smaller concentrations of Zr as consequence of chemical disorder causing interference of the photoelectron signals from Hf-Hf and Hf-Zr interactions. The lowest amplitude of the second shell features are observed for 25% Zr.

Exactly the same effect is observed for the Zr K-edge in Figure 2b. However, we note that in case of an even random distribution of Zr and Hf atoms, the Hf-Me feature in the FT-EXAFS is very diffuse in case of 50% concentration of Zr and Hf, while it is sharper for the Hf L3-edge. The transformation between the spectra of the pure oxide toward what is seen for the largest admixture of the "foreign" metal atom, occurs earlier for the Hf than for the Zr edge.

Figure 3. Calculated configuration-averaged XANES spectra of the O K-edge for the monoclinic P2₁/c, orthorhombic Pca2₁ and tetragonal P4₂/nmc polymorphs of pure HfO₂ (a), and the effect of Hf substitution with Zr for monoclinic $Hf_{1-x}Zr_xO_2$. The energy scale is relative to the absorption edge.

Moreover, O K-edge XANES simulations (Figure 3) were performed using FDMNES code (version of March 2019)⁷⁵ and the same configuration averaging of the spectra for all non-equivalent atomic positions and all possible Zr

substitutions of Hf. We used the finite difference method, which is more suited for soft X-ray XANES calculations than Green function formalism⁷⁵, and self-consistent potential calculations. We calculated XANES spectra for clusters with the radius 6.42 Å (monoclinic) and 8 Å (orthorhombic and tetragonal) for all non-equivalent O positions with subsequent configuration averaging of the spectra.

In the O K-edge XANES of Figure 3a, we see an enhancement of two peaks corresponding to the empty e_{g} and t_{2g} states of the Hf 5d or the Zr 4d orbitals⁶¹ with increasing symmetry. The tetragonal phase has the most pronounced features, but also a difference between the monoclinic and the orthorhombic phase is seen especially for the first peak.

The oscillations following these peaks (especially around 20 eV and above) correspond to the beginning of the EXAFS signal and photoelectron transitions to the continuum state. These oscillations are very distinctive for tetragonal phase. They can be used as a clear fingerprint of the tetragonal phase while the differences between monoclinic and orthorhombic phases are not significant in this part of spectra.

To discriminate effects caused by chemical substitution from structural changes, we also calculated the O K-edge XANES for the monoclinic phase of $H_{1-x}Zr_xO_2$ compounds with x = 0, 0.25, 0.5, 0.75, 1 (Figure 3b). Here, we see a pure chemical effect as structure remained the same for all Zr concentrations. This chemical effect manifests itself mainly in a shift of the second peak toward lower energies with increasing of Zr content. This is due to the energy difference of the Zr 4d and Hf 5d (the energy gap between e_g and t_{2g} states is smaller for ZrO₂ compared to HfO₂). But the relative intensities and shape of the features does not vary as much as for a change of structure in Figure 3a. Only a small decrease of the amplitude for the second peak is observed. Also, the post-XANES oscillations above 10 eV are very close (slightly moving to lower energies with increase of Zr concentration) as expected because the structure is the same and only the Zr concentration changes.

3 EXPERIMENTAL

Powders were prepared to obtain reference phases for the most relevant $HfO₂:ZrO₂$ compositions and all accessible polymorphs. Hafnia and zirconia powder samples are both monoclinic. Alloys of these compounds in bulk form are also monoclinic. Therefore, hafnia-yttria was used to stabilize a cubic powder reference. A tetragonal powder reference, however, could not be achieved.

Pure zirconia and hafnia powders were commercial precursors obtained from Tosoh, (Lot ZY000013P) and ABCR (Lot AB174486), respectively. The 50:50 mixtures of hafnia-zirconia and hafnia-yttria were fabricated using conventional solid-state processing methods by doping HfO₂ powder with 50 at% Y and 50 at% Zr. The starting powders used were HfO₂ (99.95 % purity), Y₂O₃ (99.95 % purity), and ZrO₂ (99.70 % purity) purchased from Alfa Aesar. Each of the starting powders was weighed using an analytical balance. HfO₂ was combined with the respective secondary powder material (Y_2O_3 or ZrO₂) and the powder mixtures were ball milled using ethanol as a solvent and zirconia milling media. Ball milling was used to decrease the particle size of the powder materials. Once ball milling was completed, the milling media were removed, and the powders were dried in an oven at \sim 100 °C for ~24 hours. The dried powder materials were heat treated at 1500 °C for 2 hours. XRD analysis of the powders was performed using a PANalytical X'Pert PRO diffractometer equipped with multichannel solid-state detector PIXcel. Cu anode X-ray tube was operated in the 45 kV/40 mA regime ($K_{\alpha1,2}$ radiation was used to obtain diffraction patterns). Diffraction patterns were recorded from 2*θ* = 15° to 90° with a step size of 0.0263°.

Thin film capacitor stacks consisting of 12 nm TiN (physical vapor deposition) for top and bottom electrode and 20 nm of HfO₂, Hf_{0.5}Zr_{0.5}O₂, Hf_{0.25}Zr_{0.75}O₂ or ZrO₂ (atomic layer deposition – ALD) were deposited on 125 µm thick rigid graphite obtained from Goodfellows (product number C 000400) and, as a reference for electrical characterization, also on Si substrates. Details of the procedure can be found elsewhere⁷⁶. The capacitor stacks were annealed at 600 °C for 20 s in N₂ atmosphere. On the silicon-based references, 10 nm Ti as adhesion layer and 30 nm Pt were deposited through a shadow mask by electron beam evaporation to form circular contact pads of 200 μ m diameter. These pads served as hard mask for the subsequent wetchemical removal of the TiN top electrodes in a mixture of NH₄OH, H₂O₂ and H₂O (1:2:50) at 50 °C. Polarization hysteresis of these samples was measured using

an aixACCT TF Analyzer 3000 with triangular field sweeps of 1 kHz frequency. Grazing incidence X-ray diffraction (GIXRD) was performed on all thin film samples using a Bruker D8 Discover with Cu-K_α radiation (wavelengths: 0.154 nm).

X-ray absorption spectra of bulk reference and multi-stack thin film samples have been measured at PETRA III, beamline P-65 at DESY, Hamburg. The powders were mixed with cellulose and pressed into pellets. The thin films on carbon were cut to pieces of 5 mm by 5 mm and 16 of them stacked between two layers of Kapton tape. Up to four of these packages were put into the X-ray to guarantee a reasonable absorption jump close to one. Three energy scans were performed for both the Zr K-edge and the Hf L₃-edge at room temperature. Each single scan required 180 s and covered the energy range from 150 eV below the edge to 1000 eV above the edge, as the natural oscillation damping due to thermal and static disorder effects and signal noise in our experimental setup does not allow to obtain longer signal. X-rays were generated by an undulator and monochromatized by a double crystal monochromator using the Si(111) crystal for the Hf L₃-edge (9561 eV) and the Si(311) crystal for the Zr Kedge (17998 eV). The two energy scales were calibrated using a Hf and a Zr foils. Higher harmonics were suppressed by using two plane mirrors, Si/Si (2 mrad) in case of the Hf L₃- and Rh/Rh (2 mrad) in case of the Zr K-edge.

The XAFS spectra were recorded in transmission mode using three ionization chambers with proper gas mixtures to measure the incoming intensity, and the intensities after the sample and the reference foil located in between the second and the third ionization chambers.

Oxygen K-edge XANES spectra were recorded at room temperature in fluorescence mode at the plane grating monochromator (PGM) beamline⁷⁷ of PTB at the BESSY II electron storage ring. This undulator beamline provides soft X-ray radiation of high spectral purity and high radiant power in the photon energy range of 78 eV to 1860 eV. Depending on the operational parameters, stray light contributions of about 0.5 % to 1 % have to be taken into account. The uncertainty of the energy scale of the PGM is in the 10^{-4} range. For the calibration of the PGM energy scale, typical resonance lines of Kr, Ar and Ne gases are used⁷⁸.

The experiment was carried out using an in-house developed ultrahigh vacuum chamber 79 . The samples were excited using an incident angle of 45° to suppress any attenuation effects and the emitted oxygen K_{α} fluorescence radiation was detected using a calibrated silicon drift detector under an angle of 45°. For normalization purposes, the photon energy dependent incident flux of the beamline was measured before using a calibrated photodiode.

X-ray absorption measurements over Si:HfO₂ thin films were performed at CLAESS beamline⁸⁰ at the ALBA synchrotron facility. A wiggler source was monochromatized by means of a Si(111) double crystal monochromator, while Rh-coated mirrors were exploited to reject higher harmonics. The spectra were recorded at room temperature in fluorescence mode by means of a single channel silicon drift detector. Several scans were acquired to ensure spectral reproducibility and good signal-to-noise ratio.

All X-ray absorption spectra were extracted and processed using the standard approach⁵⁴ and the software Athena⁸¹. Fourier transformations were performed using a Kaiser-Bessel window function and a k-space range of $3 - 13 \text{ Å}^{-1}.$

4 RESULTS AND DISCUSSION

First, the results on powder reference samples will be shown and explained. After that, the characterization of the thin film capacitor samples is presented and discussed for consistency between electrical and structural data as well as in comparison to similarities or differences with the powder references.

4.1 Powder References

Rietveld refinements of the XRD data were performed with the software Profex⁸². The refined diffraction pattern of the undoped hafnia powder is exemplarily shown in Figure 4 while the other refinement curves can be found in the Supporting Information S1 together with the unit cell parameters. Rietveld refinements of the diffraction patterns of both ZrO₂ and Hf_{0.5}Zr_{0.5}O₂ powder showed that both are single-phase monoclinic. For the pure HfO₂ powder, the refinement yields a mixture of monoclinic and tetragonal phases (see inset of Figure 4). The lattice

constants of the monoclinic Hf_{1-x}Zr_xO₂ phase increase with increasing Zr content. The diffraction pattern of the $Hf_{0.5}Y_{0.5}O_{2x}$ sample revealed a small amount of Y_2O_3 which is not incorporated in hafnia structure and two cubic $Hf_{0.5}Y_{0.5}O_{2-x}$ phases. Both cubic phases can be described with the same space group Fm3m, but with slightly different lattice parameters of 5.22 Å and 5.16 Å. Large peak broadening and peak overlapping does not allow determination of the crystallite sizes of the cubic phases. The final weighted profile R-factor (R_{wp}) is close to the expected R-factor (R_{exp} – best possible R_{wp} for given data set) in every refinement. Some larger discrepancies between calculated diffraction pattern and the experimental one are observed for the $H_{0.5}V_{0.5}O_{2-x}$ sample, which is indicated by a lower goodness of fit value⁸³ – $\chi^2 = (R_{wp}/ R_{exp})^2$ than for the other powders (see Supporting Information S1). Table 1 summarizes the results. A stabilization of the tetragonal polymorph in hafnia/zirconia based powders at ambient conditions is unlikely, which is a consequence of their phase diagram with a tetragonal phase only occurring above 1000 °C.⁸⁴ Therefore, we rely on unit cell data from ab-initio simulation by Materlik et al.³⁹ as depicted in Figure 1. These ab-initio results were reported to be in good agreement with the temperature dependent phase diagrams of hafnia and zirconia bulk materials.

Figure 4. Example of X-ray diffraction pattern and Rietveld fit of the undoped HfO2 powder. The inset shows the magnified region around 2θ = 30° with separated reflections of the monoclinic and tetragonal phases.

Table 1. Results of Rietveld refinements of the diffraction patterns for the bulk reference samples.

Composition	Phases (wt%)	a (Å)	b (Å)	C (Å)	β (°)
ZrO ₂	100 monocl.	5.148	5.211	5.313	99.19
$Hf0.5Zr0.5O2$	100 monocl.	5.135	5.194	5.306	99.25
HfO ₂	82 ± 1 monocl.	5.131	5.172	5.305	99.11
	$18 + 1$ tetrag.	3.593 5.185		90	
$Hf_{0.5}Y_{0.5}O_{2-x}$	7±1 Y_2O_3	10.599			90
	56 ± 1 cubic I	5.221			90
	37 ± 1 cubic II	5.164			90

The Hf L₃-edge X-ray absorption near edge structure (XANES) spectra of the HfO₂, Hf_{0.5}Zr_{0.5}O₂ and Hf_{0.5}Y_{0.5}O_{2-x} powders show trends consistent with the structure data, but do not allow for deeper insights with respect to the structure. It appears that electronically, the samples have very similar electronic structure. A comparison and related discussions can be found in in the Supporting Information S2.

The EXAFS parts of the spectra exhibit distinct features for the pure HfO₂, Hf_{0.5}Zr_{0.5}O₂ and Hf_{0.5}Y_{0.5}O₂ x powders as shown in the FT-EXAFS in Figure 5. The corresponding EXAFS spectra are presented in Supporting Information S5. The overall impression is very straightforward: the local structure of Zr for the bulk samples does not change a lot, as all features in the Zr K-edge EXAFS spectra and corresponding FT-EXAFS are the same within range of our spectra (Figure 5b). This is in line with XRD data where $Hf_{0.5}Zr_{0.5}O_2$ and the ZrO₂ look to be 100 % monoclinic. The first coordination shell (Zr-O) has the least changes indicating that ZrO₇ polyhedra retain the same statistics (combination of distances and their variation) which is expected as both compounds have the same monoclinic symmetry.

At the same time, the decrease in FT-EXAFS amplitude for second coordination shell could be correlated to the mixture of the atoms in the second coordination shell (Zr-Me, where Me = Zr, Hf). However, our simulations suggest that this feature should be significantly lower and more diffuse (see Figure 2 (b) for 50 % of Zr). This might indicate that the second coordination shell of Zr might have higher concentration of Zr atoms than we expect in the case of a random distribution. We see this as a sign of Zr segregation in some small clusters (can be even just a higher than a statistically averaged concentration of Zr-O-Zr groups compared to Zr-O-Hf ones).

The local structure of Hf represented by the Hf L₃-edge EXAFS and FT-EXAFS behaves close to the theoretical calculations for monoclinic structure. The FT-EXAFS features corresponding to the first shell (Hf-O) are very close, especially for HfO₂ and Hf_{0.5}Zr_{0.5}O₂ as in HfO₂, the monoclinic phase dominates. This is supported by our theoretical modelling for Hf L3-edge of the mixture of monoclinic and tetragonal phase, which is in line with experimental spectra (Figure 5a, Figure S16b in supporting information) where in both we see a single peak for Hf-O and double peak for Hf-Hf coordination shells.

The slight increase of the maximum amplitude of Hf-O feature in FT-EXAFS for $Hf_{0.5}Y_{0.5}O_{2-x}$ (Figure 5a) is expected due to narrower distance distribution in cubic phase, but the difference should be much bigger (Figure 1b) if we had a single pure cubic phase instead of two as detected by XRD.

Figure 5. (a) Hf L3-edge and (b) Zr K-edge FT-EXAFS for HfO2, Hf0.5Zr0.5O2, Hf0.5Y0.5O2-y, ZrO2 powders. For the Hf L3 edge a theoretical spectrum of a mixture of 80 % monoclinic and 20 % tetragonal phase is provided (Please note that the amplitudes at higher R values are more pronounced as explained in the beginning of section 2). The vertical dashed lines are provided just for guidance to highlight the changes between the main peaks of the Me-O and Me-Me coordination shells. Note that the distances do not correspond to the real distances due to phase shift of the photoelectron. Distances for Hf and Zr are not comparable as this phase shift is different for Hf and Zr. However, the distances of the respective Hf or Zr edges can be compared between Figure 5 and Figure 9.

The changes in the second coordination shell of Hf (Hf-Me) with the composition are more pronounced, so it contains more useful information to study composition and structure evaluation than the first coordination shell. Comparing the FT-EXAFS features corresponding to the second coordination shell of Hf for HfO₂ and Hf_{0.5}Zr_{0.5}O₂ it can be seen that the major difference is the feature at 3.3 Å. This feature is close to the maximum of the corresponding feature for cubic phase and calculated tetragonal phase. Here, the EXAFS data support the XRD finding that this is a mixture of monoclinic and tetragonal phase as our theoretical spectra for monoclinic and tetragonal phase mixture match the experimental one (Figure 5a). The maximum of the Hf-Me feature for Hf $_{0.5}Zr_{0.5}O_2$ moves to shorter distances slightly below 3 Å because of two effects: The tetragonal phase disappears because this sample has a pure monoclinic phase. Moreover, adding 50% of Zr shifts the feature of the second shell to shorter distances and changes shape as the theoretical calculations in Figure 2 show. We can confirm the findings form the Zr K-edge data: The amplitude of the Hf-Me signal does not correspond to 50 % Zr but is somewhere between 25% and 50% Zr. This shows that the concentration of Zr in the second coordination shell of Hf is lower than expected from an even distribution of Zr and Hf atoms. This finding is based on a comparison of the relative amplitudes for the model spectra for hafnia with 80:20 mixture of monoclinic and tetragonal phase with model spectra for $H_{0.5}Zr_{0.5}O_2$ and $H_{0.75}Zr_{0.25}O_2$ (Figure S18 in Supporting Information) with the proportions in the experimental spectra for HfO₂ and $Hf_{0.5}Zr_{0.5}O_2$ powders.

Comparing Zr K-edge and Hf L₃-edge spectra for HfO₂, Hf_{0.5}Zr_{0.5}O₂ and ZrO₂, we can conclude that for the Hf_{0.5}Zr_{0.5}O₂ bulk material, the local structure of Zr and Hf does not correspond to an even distribution of Zr and Hf atoms on the lattice sites of the unit cells (Figure 2 and Figure 5). This is a sign of nano-segregation of having more Zr in the second coordination shell of Zr and more Hf in the second coordination shell of Hf than expected from statistically even distribution. It should be noted that no ordering of Hf and Zr atoms in any superstructures or a phase separation were detected in XRD measurements.

3.2 Thin Film Capacitor Stacks

Figure 6 shows the basic electrical and structural characterization of the chosen hafnia-zirconia compositions between TiN electrodes on Si substrates. As expected from previous works^{76,85}, ALD-deposited pure hafnia exhibits a monoclinic phase in the grazing incidence X-ray diffraction (GIXRD) patterns (Figure 6b), related with linear dielectric behavior (Figure 6a). Figure 6, panels b and c, compares the GIXRD patterns collected for different zirconia contents for film stacks on a Si and on a rigid graphite substrates. The latter were used for the X-ray absorption spectroscopy experiments. For increasing zirconia content, hysteretic curves appear. For the 50:50 mixture, a ferroelectric hysteresis is seen, which is related with the orthorhombic phase, but not phase-pure as the GIXRD pattern suggests. A significant amount of monoclinic phase is present in the film and even the existence of tetragonal grains cannot be ruled out from these patterns with broad and overlapping peaks. However, as the tetragonal phase gives rise to antiferroelectric properties and a pinched hysteresis like for the Hf_{0.25}Zr_{0.75}O₂ and the ZrO₂ films, significant portions of tetragonal phase are unlikely. Comparing the GIXRD results on Si with those on C substrate as used for the x-ray absorption measurements, the $H_{0.5}Zr_{0.5}O_2$ samples exhibits even higher monoclinic peaks making the presence of a tetragonal phase even less likely if we rely on the general trends explained by Hoffmann et al.¹⁸. For even higher Zr content, antiferroelectric behavior and a tetragonal phase are observed. Due to the brittle constitution of the graphite substrate, electrical measurements were not possible. The striking similarity of their GIXRD patterns (Figure 6c) to those of the reference film stacks on silicon allows us to conclude on the presence of comparable phase fractions and thus, comparable dielectric behavior. Just a slightly trend toward more monoclinic phase fractions can be concluded from the comparison of Figure 6b and c. With these vital prerequisites met, we can proceed to the discussion of the EXAFS measurements below.

The Hf L₃-edge EXAFS obtained from a single Si:HfO₂ (1 at%, ratio of Si/[Hf+Si+O]⁴⁵) thin film deposited on a 675 µm thick Si substrate obtained in a preliminary fluorescence mode measurement at the CLAESS beamline at the ALBA synchrotron facility is compared to the signal recorded using the multi-stack approach for a pure HfO₂ film in Figure 7 (details and full data, see Supporting Information S4). Both signals are similar, as they both correspond to the monoclinic phase. However, there is an obvious difference in the quality of the EXAFS data, especially for values of the wavenumber *k* above 8 Å⁻¹. The quality of the signal obtained from stacking multiple thin film capacitors on the thin carbon substrate is comparable with that of the bulk references (see FT-EXAFS in Figure 5 and EXAFS data in Figures S8 and S9 in the Supporting Information). This clearly proves the advantages of this approach compared to measuring a single hafnia film in fluorescence mode as it has been done previously by the authors and other groups⁸⁶.

Similar to the observation for the bulk references, the XANES results for the Hf L_3 - and the Zr K-edge only allow limited conclusions. However, the trends are more pronounced then for the bulk samples as the changes in phase composition are more significant in the thin films. A more detailed discussion of the spectra can be found in the Supporting Information S3.

XANES measurements at a soft X-ray beamline, the PGM beamline⁷⁷ of the PTB at BESSY II were performed to check whether the sensitivity of the O K-edge is sufficient to see marked changes in the spectra. The O K-edge XANES spectra reported in Figure 8 show significant differences. The spectra consist of two main features around 532 eV and 536 eV, corresponding to the empty e_g and t_{2g} states of Hf 5d or Zr 4d, followed by a broader and more complex peak sequence starting at 540 eV, which originates from Hf 6sp and Zr 5sp empty hybrid states, hybridized with the O 2p bands^{58,61,63}. The shoulder at 531 eV most likely stems from the interface states (probably Ti-O as all thin films are sandwiched between TiN layers 87 , or a C=O signal from carbon substrate).

Figure 6. (a) Polarization vs. electric field curves from dynamic hysteresis measurements of the hafnia-zirconia based films and (b) corresponding grazing incidence X-ray diffractograms for the different zirconia contents for reference stacks on a Si substrate as the base of the observed dielectric behavior. (c) Grazing incidence X-ray diffractograms of the film stacks on rigid graphite substrates that were used for the X-ray absorption spectroscopy experiments.

The O K-edge XANES data give more profound information about structural transformations (compared to the Hf L₃-edge or Zr K-edge) and support a transformation of the spectra from monoclinic toward tetragonal as seen for the post-XANES oscillations, e.g. around 555 eV. These changes are in line with theoretical calculations presented in Figure 3. For 75 % ZrO₂ content, the electronic local structure for oxygen looks almost identical to the one of pure ZrO₂.

Figure 7. Hf L3-edge, EXAFS spectra for a single Si:HfO2 thin film on Si in fluorescence mode and multiple stacks of a HfO2 film on carbon in transmission mode.

Moreover, it can be seen that the $Hf_{0.5}Zr_{0.5}O_2$ thin films show noticeable differences to monoclinic structure of HfO2 thin films in this region above 545 eV. However, this is most likely due to the impact of substituting Hf with Zr as our theoretical modelling indicates. The differences between monoclinic and orthorhombic structures in Figure 3 are small compared to changes found for chemical substitution.

The shift of the t_{2g} peak to lower energies (decreasing gap between e_g and t_{2g} states) is also caused mainly by the substitution of Hf with Zr as explained in the simulations section. The sharpening of these features, on the contrary, is a signature of structural transformations (especially the sharpening of the first peak) as found in our theoretical calculations. It should be noted that the simulated spectra for the monoclinic phase do not reproduce the experimental spectra very well. The simulated spectra exhibit much broader and less defined features at 533 eV than the experimental ones. This is likely due to issues with the self-consistent calculations of the XANES spectra leading to different positions of the Fermi level for different absorbers or a too broad distribution of Me-O distances in the model (as compared to reality). Both of these effects might lead to broader spectral features. Nonetheless, the predicted trends of the transformation of the XANES spectra are well aligned: 1) From a monoclinic to a tetragonal phase, a broader multi-peak structure transforms into a two-peak structure. 2) From HfO₂ to ZrO₂, the features shift to lower energies.

So, in the O K-edge as well as in the Zr K-edge and Hf L₃-edge XANES spectra (see Supporting Information S3), we can consistently observe a gradual transformation from monoclinic to tetragonal phase as the Zr content of the films increases.

Figure 8. O K-edge XANES spectra for Hf_{1-x}Zr_xO₂ <i>thin films showing gradual transformation of the spectra from monoclinic (pure HfO₂ thin film) to tetragonal phase (pure ZrO₂ thin film). The arrow indicates the trend of the most prominent changes in the spectra. Figure S6 in the Supporting Information shows the corresponding Hf L3 and Zr K-edge spectra.

A comparison of the FT-EXAFS spectra obtained on the Hf L_3 - and Zr K-edge for Hf_{1-x}Zr_xO₂ multi-stack thin films samples is reported in Figure 9 (see Figure S9 in the Supporting Information for the corresponding EXAFS spectra). Comparing the results to those in Figure 5, it can be concluded that the local structure of Hf in the pure HfO₂ thin films is close to that of the bulk samples, while for the ZrO_2 , bulk and thin film spectra are significantly different– the former being related to a monoclinic the latter to a tetragonal phase.

The close similarity of HfO₂ thin film, the powder reference and theoretical spectra for pure monoclinic phase suggests that the monoclinic phase is dominant. While the powder contains 80 % of the tetragonal phase, the GIXRD pattern of the thin film (Figure 6) does not show any noticeable traces of the tetragonal phase. Another simple explanation for why the EXAFS spectra still look very similar (beyond the dominating monoclinic phase mentioned before) is that if fractions of the tetragonal phase might be present in the thin films, the size of the corresponding crystallites is much smaller resulting in a very weak contribution to the GIXRD data.

The Hf L₃-edge spectra of the ferroelectric Hf_{0.5}Zr_{0.5}O₂ thin film shares some similarity with the one of monoclinic bulk Hf_{0.5}Zr_{0.5}O₂, but the signal from the second coordination shell Hf-Me exhibits some differences: It is narrower and slightly shifted to shorter distances compared to bulk (Figures S9-S10 in the Supporting Information). If we compare this to our calculations for the substitution of Hf with Zr (Figure 2), we see that this corresponds exactly to the case of 50 % Zr where the peak of the Hf-Me feature shifts to shorter distances and becomes narrower.

At the same time, the Zr K-edge FT-EXAFS spectrum for the same $Hf_{0.5}Zr_{0.5}O_2$ thin film is clearly different from that of the powder reference with the same composition. The second and further coordination shells are more disordered and do neither match the tetragonal (as for ZrO₂ thin films) nor the monoclinic (as for Hf_{0.5}Zr_{0.5}O₂ bulk samples) reference spectra. However, the thin film data is in excellent agreement with our model calculations for $Hf_{0.5}Zr_{0.5}O_2$ with random distribution of Zr and Hf in the second (and further) coordination shell of Zr. This together with the FT-EXAFS data for the Hf L₃-edge, this might be a good indicator for a uniform distribution of Zr and Hf atoms in the films. According to GIXRD and the dielectric measurements in Figure 6, the thin film is expected to be a mixture of mainly monoclinic and orthorhombic phase. This is also in line with the EXAFS data, as differences in the spectra of these two phases are expected to be small (Figure 1a). Altogether, this raises the question, who is responsible for the ferroelectricity. Is it Hf, Zr or it is an integral effect of both? The Hf L₃-edge spectrum for the $Hf_{0.25}Zr_{0.75}O_2$ looks different from both the spectra of the Hf_{0.5}Zr_{0.5}O₂ and of the HfO₂ thin films indicating not only chemical, but also structural differences. In FT-EXAFS, a double feature is found for the first shell of Hf (Hf-O),

which is characteristic for the tetragonal phase as follows from our theoretical calculations of EXAFS spectra (Figure 1). At the same time, a feature corresponding to the second coordination shell is more disordered, which is in better agreement with the model spectra (Figure 2 as well as Figures S13 and S14) for tetragonal phase with significantly lower Zr concentration. In the tetragonal $Hf_{0.25}Zr_{0.75}O_2$ model compound of the monoclinic phase, the Hf-Me feature is much more pronounced than for lower concentrations of Zr. The same, however, applies also for monoclinic and orthorhombic model systems, where the height of the FT-EXAFS feature for second coordination shell is maximal for the highest Zr concentrations. This is mainly strongly impacted by a chemical effect, while the first coordination shell reflects mainly the structural effect.

Figure 9. (a) Hf L3-edge and (b) Zr K-edge FT-EXAFS for Hf1-xZrxO2 (x = 0, 0.5, 0.75, 1.) thin films. The vertical dashed lines highlight the shifts between the main peaks of the Me-O and Me-Me shells when comparing the Hf and the *Zr edge spectra. Note that the distances do not correspond to the real distances due to phase shift of the photoelectron. Distances for Hf and Zr are not comparable as this phase shift different for Hf and Zr. However, the distances of the respective Hf or Zr edges can be compared between Figure 5 and Figure 9. Corresponding EXAFS files are shown in Supporting Information Figure S10.*

The Zr K-edge spectra for $H_{0.25}Zr_{0.75}O_2$ and ZrO₂ thin films show features characteristic for the tetragonal phase. The only difference is found in the amplitude of the spectra, which can be attributed to the chemical disorder from mixing Zr and Hf as evidenced by our model calculations (Figure 2). The only remarkable difference is that we do not see the double feature for Zr-O in the first coordination shell, which is a fingerprint of the tetragonal phase. This might hint on dynamic correlation effects. The dynamic correlation effects might change the shape of radial distribution function (RDF)⁸⁸. Dielectric and GIXRD measurements (Figure 6) show that these thin films are tetragonal and antiferroelectric. This can be due to a pseudo-symmetry effect: The Me atoms occupy a set of tetragonal positions, which dominate the measured XRD signal. The O atoms might, however be closer to the positions in the cubic unit cell, which would not result in two distinct Me-O distances.

Given that the orthorhombic phase shares some similarities with the monoclinic phase⁸⁹ and the transition state between the two polarization states has been described as an orthogonalized monoclinic phase⁹⁰, the interpretation data for thin films becomes a complex subject. Moreover, Grimley et al.⁵⁰ showed the coexistence of multiple phases within one grain that relax into one another from one unit cell to another. Future data analysis based on reverse Monte Carlo simulations in combination with neural network approach and spectra acquired at different temperatures will help deciding which of the two explanations is more accurate.

5 CONCLUSION

The theoretical EXAFS spectra presented in the beginning of this work show that good data quality is warranted to distinguish the relevant phases in hafnia and zirconia. Differences in the spectra of the monoclinic, orthorhombic, tetragonal and cubic phases are mainly observed in the second and higher coordination shells. Targeting the analysis of polycrystalline, only some tens of nm thick films, we therefore, started with powder samples to obtain reference spectra free of thin film effects. The experimental data of the powder references matched well with the theoretical spectra anticipated from the phase composition extracted from XRD via Rietveld refinement and unit cell data from ab-initio simulations. The XANES features and the position of the absorption edges of the powders look very similar hinting on comparable electronic structure despite the apparent differences between the unit cells (compare images in ref. 39).

For all powder compositions, we found a similar local structure for Hf and Zr. Our pure HfO₂ powder is a mixture of monoclinic and tetragonal phase. This questions the usability of this bulk material as a reference samples.

Only the $Hf_{0.5}Zr_{0.5}O_2$ might be used as a reference sample, where both Hf and Zr exhibit a monoclinic local structure. But even in this case, comparing Zr K-edge spectra for $Hf_{0.5}Zr_{0.5}O_2$ and ZrO₂ with the model calculations, we conclude that for the monoclinic Hf_{0.5}Zr_{0.5}O₂ bulk material, the local structure of Zr and Hf differs from that of a random distribution of Zr and Hf atoms because the experimental data (Figure 5) does not agree with the simulations for monoclinic Hf_{0.5}Zr_{0.5}O₂ (Figure 2). We see a sign of having more Zr-O-Zr and Hf-O-Hf structures than expected from statistically even distribution showing that synthesis of a solid solution with statistically random distribution of Hf/Zr atoms is a challenging task.

The cubic structure of the Y₂O₃:HfO₂ mixture has a clearly different appearance also in the experimental EXAFS spectra of the bulk samples. Features corresponding to the second coordination shell of the metal (here Hf) seen in the FT-EXAFS around 3 Å in Figure 5a are not as sharp and pronounced as expected for single cubic phase. This is in line with the Rietveld results that concluded the presence of two cubic hafnia-yttria phases combined with a chemical mixture of Y and Hf atoms and including a small presence of Y_2O_3 (7%). Moreover, it is likely that the non-ideal random distribution of the substitute element into the Hf sites found for $Hf_{0.5}Zr_{0.5}O_2$, also makes the features of the Y_2O_3 :HfO₂ powder less sharp than in theory due to the static disorder.

So, we can summarize that obtaining good single-phase bulk Hf_1 _xZr_xO₂ and Hf_0 ₅Y_{0.5}O_{2-x} reference compounds with random distribution of atoms is still an open challenge.

Thin films ranging from paraelectric monoclinic via ferroelectric orthorhombic to antiferroelectric tetragonal were fabricated and analyzed via GIXRD and P-E hysteresis measurements. The simple approach of measuring a single 10 nm thick film on Si in fluorescence mode was shown to be insufficient to obtain the required data quality that allows the analysis of higher coordination shells. Therefore, capacitor stacks were fabricated on thinner C substrates and stacked on top of one another. A signal quality comparable to the bulk samples could be achieved.

The trends in XANES and EXAFS could be correlated with GIXRD and P-E measurements as well as with the bulk measurements. A gradual transformation from a monoclinic to a tetragonal phase could be found in Hf L₃₋, Zr Kand O K-edge XANES spectra, with most prominent changes found in the latter ones.

The O K-edge XANES data (Figure 8) give more profound information about structural transformations compared to Hf L₃-edge or Zr K-edge, where the energy resolution is worse due to core-hole lifetime effects, which results in a smoothening of all features. The O K-edge XANES spectra support a transformation of the spectra from monoclinic to tetragonal as is very evident from the post-XANES oscillations (compare Figure 3). With 75 % of ZrO₂ content, the electronic local structure for oxygen looks almost identical to the one of pure $ZrO₂$.

Also, the $Hf_{0.5}Zr_{0.5}O_2$ thin films show noticeable differences in this post-XANES (early EXAFS) region compared to monoclinic structure of the HfO₂ thin films. This effect, however, is most likely due to the substitution of Hf with Zr as indicated by in our theoretical modelling (Figure 3). The differences between monoclinic and orthorhombic structures are smaller compared to the changes cause by chemical substitution.

The shift of the t_{2g} peak to the lower energies (decreasing gap between e_g and t_{2g} states) is also mainly caused by the substitution of Hf with Zr, while the sharpening of these features is a signature of additional structural transformations (especially sharpening of the first peak) as seen in our theoretical calculations (Figure 3).

Similar trends are found in the EXAFS spectra. The thin film spectra look comparable to the bulk reference spectra. While monoclinic HfO₂ and the orthorhombic Hf_{0.5}Zr_{0.5}O₂ films appear rather similar, there is an obvious difference to the tetragonal $Hf_{0.25}Zr_{0.75}O_2$ and ZrO_2 films.

For the Hf_{0.5}Zr_{0.5}O₂ thin films both data (Zr K-edge and Hf L₃-edge) correspond well to the model system with uniform distribution of Zr and Hf atoms in a monoclinic or orthorhombic lattice (Figure 2, Figure S13 and Figure S14). This can be well-explained by the difference between the gas phase deposition and the powder fabrication route: While in ALD, ZrO₂ and HfO₂ sub-monolayers are deposited alternatingly, crystallites of ZrO₂ and HfO₂ are being mixed in the powder route. Before the high-temperature step (rapid thermal anneal or calcination), the distance that Zr as well as Hf atoms need to diffuse to establish a perfectly random distribution are about a factor of 100 larger (a few Å vs. a few tens of nm). This suggests that powders are not always a very suitable reference system if the high-temperature step was not able to uniformly distribute Hf and Zr in the final product. We want to emphasize that this conclusion has impact that potentially extends beyond the system of hafnia-zirconia studies in this work.

For the Hf_{0.25}Zr_{0.75}O₂ thin film, the Hf L₃-edge spectrum supports a tetragonal structure. We see in FT-EXAFS a double feature for the first shell of Hf (Hf-O) which is characteristic for the tetragonal phase as follows from our theoretical calculations (Figure 1b). At the same time, the features of the second coordination shell are more disordered, which fits better to the model spectra (Figure 2) with significantly lower Zr concentration. In the tetragonal Hf_{0.25}Zr_{0.75}O₂ model (Figure S13) compound, the Hf-Me feature should be much more pronounced compared for other phases (e.g. monoclinic HfO₂ and orthorhombic Hf_{0.5}Zr_{0.5}O₂).

The Zr K-edge spectra of both $Hf_{0.25}Zr_{0.75}O_2$ and ZrO₂ thin films show features characteristic for the tetragonal phase. The difference in the amplitude of spectra is attributed to the chemical disorder mixing Zr and Hf as shown by our model calculations (Figure 2 and Figure S14). The only remarkable difference to the model calculations is that we do not see a double feature for Zr-O in the first coordination shell, which might be a sign for dynamic correlation effects. The dynamic correlation effects might change the shape of radial distribution function (RDF)⁸⁸. Another option is a pseudosymmetry with tetragonal lattice parameters and cubic oxygen positions as GIXRD mostly gives signal from metals.

Future studies will focus on how temperature dependent structure evolution is reflected in the spectra of thin film as well as powder reference samples. No temperature dependent data has been reported and analyzed even for the common bulk polymorphs such as the monoclinic, tetragonal or cubic phase. In thin films, an understanding of static and dynamic disorder is crucial as the situation with potentially multiple phases, size-effects, strain, vacancies or dopants is complex enough to pose a severe challenge. Advancing the understanding of the bulk phases will be the key to a full picture of what happens in these para-, ferro- and antiferroelectric thin films that are of great scientific and technological interest.

SUPPORTING INFORMATION

Details on the Rietveld refinement for the powder samples and the corresponding fit curves, a discussion of the XANES data for both bulk and thin films, the XANES and EXAFS results for the fluorescence mode measurement of the Si:HfO₂ single-layer thin film sample and some additional EXAFS spectra of bulk and thin films can be found in the Supporting Information. This material is available free of charge via the Internet at http://pubs.acs.org.

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